

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Attn: APPLICATION BRANCH**
Tetsuji TOGAWA et al. : Attorney Docket No. 2004_0624
Serial No. NEW :
Filed April 20, 2004 :

APPARATUS FOR MANUFACTURING
SEMICONDUCTOR DEVICE
**(Rule 1.53(b) Continuation
of Serial No. 09/358,252,
Filed July 20, 1999)**

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 221100/1998, filed July 21, 1998, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/358,252, filed July 20, 1999.

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Respectfully submitted,

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